IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: Tsz K. Chiu Art Unit: 2822 Confirmation No. 8692
SEIICHI TAMURA ET AL.	;	
Application No.: 10/599,427)	
Filed: September 28, 2006)	
For: PHOTOELECTRIC CONVERSION DEVICE AND MANUFACTURING METHOD THEREOF	;) ;	August 8, 2008

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION OF FULL ENGLISH TRANSLATION OF PREVIOUSLY CITED REFERENCE FOR WHICH AN ENGLISH ABSTRACT WAS PROVIDED

Sir:

Submitted herewith is a full English translation of JPA 1-243462, which was previously cited in an Information Disclosure Statement filed on September 28, 2006. A copy of this Japanese reference and an English abstract thereof were submitted with the Information Disclosure Statement.

The Examiner is respectfully requested to consider the full English translation of JPA 1-243462 provided herewith.

Although no fee is believed due, if a fee is deemed to be required than the Commissioner is authorized to charge such fee to Deposit Account No. 50-3939.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

/Lock See Yu-Jahnes/ Lock See Yu-Jahnes Attorney for Applicants Registration No. 38,667

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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